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!	Application No.	Applicant(s)	
A	10/690,250	LIN ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Alonzo Chambliss	2814	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to <u>response to an election filed on 11/24/04.</u>			
2. The allowed claim(s) is/are <u>157-190</u> .			
3.  The drawings filed on 20 October 2003 are accepted by the Examiner.			
<ul> <li>4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some* c) None of the: <ol> <li>Certified copies of the priority documents have been received.</li> <li>Certified copies of the priority documents have been received in Application No. 10/124,388.</li> <li>Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).</li> </ol> </li> <li>* Certified copies not received:</li> </ul>			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply ENT of this application.	complying with the requirements	
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
6. CORRECTED DRAWINGS ( as "replacement sheets") must	t be submitted.		
(a) I including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) ☐ hereto or 2) ☐ to Paper No./Mail Date			
(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).			
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date	6. ☐ Interview Summary Paper No./Mail Dat 8), 7. ☑ Examiner's Amendm		
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# **DETAILED ACTION**

#### Election/Restrictions

1. Applicant's election without traverse of claims 157-190 in the reply filed on 11/24/04 is acknowledged. Claims 1-156 and 191-220 have been cancelled.

# **Priority**

2. Acknowledgment is made of applicant's claim for foreign priority under 35 U.S.C. 119(a)-(d). The certified copy has been filed in parent Application No. 10/124,388, filed on 4/15/02.

# **Drawings**

3. The formal drawings filed on 10/20/03 have been approved by the examiner.

#### **EXAMINER'S AMENDMENT**

4. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

## **SPECIFICATION:**

The title has been changed to "PROCESS OF FABRICATING A CHIP STRUCTURE".

## **Allowable Subject Matter**

5. The following is a statement of reasons for the indication of allowance subject matter: the prior art of record does not teach or suggest the combination of a wafer with a plurality of electric devices and interconnection scheme arranged inside the wafer, wherein a passivation layer is disposed on the surface of the wafer with an opening exposing the interconnection scheme. A conductive layer that is over the passivation layer, wherein the conductive layer is electrically connected with the interconnection scheme. A photoresist formed on the conductive layer, wherein the photoresist has an opening exposing the conductive layer. Filling the conductive metal over the conductive layer and removing the photoresist and the conductive layer not covered with the conductive metal in claim 157.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning the communication or earlier communications from the examiner should be directed to Alonzo Chambliss whose telephone number is (571) 272-1927.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the group receptionist whose telephone number is (703) 308-7956.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system Status information for published

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applications may be obtained from either Private PMR or Public PMR. Status information for unpublished applications is available through Private PMR only. For more information about the PMR system see http://pair-dkect.uspto.gov. Should you have questions on access to the Private PMR system contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free) or EBC\_Support@uspto.gov.

AC/February 5, 2005

Alonzo Chambliss

Primary Patent Examiner

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